


Form PTO 1449 (Modified) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		DOCKET NO.		SERIAL NO.			
		005212/TCG/SPC/SB		NEW PATENT APPLICATION			
		APPLICANT		11040 U.S. PTO 09/903222 			
SHREYAS KHER, ET AL.							
LIST OF REFERENCES CITED BY APPLICANT (Use Several Sheets if Necessary)		FILING DATE		GROUP ART UNIT			
		HEREWITH		UNASSIGNED			
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
WA	AA	6,051,286	4/18/00	ZHAO ET AL.	—	—	
	AB	6,082,714	7/4/00	DORNFEST ET AL.	—	—	
	AC	6,077,562	6/20/00	DORNFEST ET AL.	—	—	
WA	AD	6,070,551	6/6/00	LI ET AL.	—	—	
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION		
	AL				YES	NO	
	AM						
	AN						
	AO						
	AP						
OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)							
	AQ						
	AR						
	AS						
	AT						
EXAMINER					DATE CONSIDERED		
WA					8/26/03		
*EXAMINER: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.							

Form PTO 1449

(Modified)

U.S. DEPARTMENT OF
COMMERCE
PATENT AND TRADEMARK
OFFICE

DOCKET NO.

005212/TCG/SPC/SB

APPLICANT

SHREYAS KHER, ET AL.

FILING DATE

JULY 10, 2001

SERIAL NO.

09/903,222

LIST OF REFERENCES CITED BY APPLICANT
(Use Several Sheets if Necessary)

GROUP ART UNIT

1762

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLAS S	SUB CLASS	FILING DATE IF APPROPRIATE
WA	AA	5,674,563	10/07/97	TARUI ET AL.	—	—	
WA	AB	5,972,430	10/26/99	DIMEO, JR. ET AL.	—	—	
WA	AC	6,162,501	12/19/00	KIM	—	—	
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION YES NO
WA	AL	WO 01/99166	06/08/01	PCT	
WA	AM	JP 60 017078	01/28/85	JAPAN (ABSTRACT ONLY)	
	AN				

OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)

WA	AO	Cho, et al., "Improvement of Dielectric Properties of (Ba, Sr) TiO ₃ Thin Films Deposited by Pulse Injection Chemical Vapor Deposition", Applied Physics Letters, American Institute of Physics., Vol. 72, No. 7, pages 786-788 (1998).
WA	AP	Tanimoto et al., "Synchronously Excited Discrete Chemical Vapor Deposition of Ta ₂ O ₅ ", Journal of the Electrochemical Society, Vol. 141, No. 5, pages 1339-1346 (1994).
	AQ	
	AR	

EXAMINER

Wes Marshall

DATE CONSIDERED 8/26/03

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